

FORM PTO-1449	Atty. Docket No.: S01.12-0992	Appl. No.: 10/645,915
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	First Named Inventor:	
	Zine-Eddine Boutaghou	
	Filing Date	Group Art:
	HEREWITH	2652

## U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
Chen	AA 4,871,899	10/3/89	DeFrenne	219	233	
	AB 5,699,212	12/16/97	Erpelding et al.	360	104	
	AC 5,757,585	5/26/98	Aoyagi et al.	360	104	
	AD 5,796,549	8/18/98	Sedbrook et al.	360	103	
	AE 5,835,306	11/10/98	Bennin	360	104	
	AF 5,889,636	3/10/99	Arya et al.	360	104	
	AG 6,078,473	6/20/00	Crane et al.	360	104	
	AH 6,318,624	11/20/01	Pattanaik et al.	228	56.3	
	AI 6,460,755	10/8/02	Inoue et al.	228	246	
	AJ 6,543,677	4/8/03	Pattanaik et al.	228	246	
	AK 2002/0057531	5/16/02	Segar et al.	360	234.5	Nov. 13, 2001
Chen	AL 2002/0113115	8/22/02	Satoh et al.	228	41	Feb. 13, 2002

## FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub Class	Translation Yes No
AM						
AN						
AO						

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Chen	AP	Cheng et al., "Localized Silicon Fusion and Eutectic Bonding for MEMS Fabrication and Packaging", 2000 IEEE Journal of Microelectromechanical Systems, Vol. 9, No. 1, pp. 3-8, March 2000.
	AQ	
	AR	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.